



PATENT  
0020-4666P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KONUSHI, et al. Conf.: 1396  
Appl. No.: 09/492,803 Group: 2828  
Filed: January 28, 2000 Examiner: QUYEN LEUNG  
For: SEMICONDUCTOR LASER DEVICE AND METHOD OF  
MANUFACTURING SAME

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LARGE ENTITY TRANSMITTAL FORM

Assistant Commissioner for Patents  
Washington, DC 20231

July 25, 2002

Sir:

Transmitted herewith is a Reply to Restriction/Election Requirement in the above-identified application.


- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ Petition for \_\_\_\_\_ ( ) month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- ☒ No fee is required.
- ☐ A check in the amount of \$0.00 is enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

Appl. No. 09/492,803

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

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